

**Search Notes**

Application No.

10/658,270

Applicant(s)

CHENG ET AL.

Examiner

Victor V Yevsikov

Art Unit

2825

**SEARCHED**

Class	Subclass	Date	Examiner
438	687,637 653,652 654,672 677,676	4/8/2004	VY
438	785,902	4/8/2004	VY
438	906	4/8/2004	VY

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
Same as above		4/8/2004	VY

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
interconnect\$4 and ((first adj plasma adj (etch\$4 or clean\$4 or treatment or anneal\$4)) same (copper or Cu)) and ((second adj	4/8/2004	VY